



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

KEN A. NISHIMURA et al

Serial No. 10/736,724

Filed: December 15, 2003

Examiner: Hung Nguyen

Group Art Unit: 2851

For: DEFECT MITIGATION IN SPATIAL LIGHT MODULATOR USED FOR
DYNAMIC PHOTOLITHOGRAPHY

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first class mail in an
envelope addressed to Mail Stop Amendment, Commissioner
for Patents, P. O. Box 1450, Alexandria, VA 22313-1450

Date of Deposit: March 9, 2006

Signature: 
Phil Rudnick

RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the final Office Action of January 19, 2006 in the
above-identified application.

Please do not enter

3/17/06

HN